

 <p style="text-align: center;"><b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)</p>	Docket number (Optional) <b>16169.6</b>	Application Number <b>10/532,550</b>
	Applicant(s) <b>Ishii, et al.</b>	
	Filing Date <b>4/22/2005</b>	Group Art Unit <b>1773</b> <b>Not Yet Assigned</b>

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
LF		6,491,572	12/10/2002	Horie, et al.	451	63	10/10/2000

U.S. PATENT APPLICATION PUBLICATIONS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
LF		2002/0127432	09/12/2002	Saito, et al.	428	694	12/17/2001

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
LF		2002/251716	06/09/2002	JP				
LF		2001/341058	12/11/2001	JP				
LF		5/342532	12/24/1993	JP				

EXAMINER <b>/Louis Falasco/</b>	DATE CONSIDERED <b>02/02/2007</b>
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**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449

10/532550

Sheet 1 of 1

Applicant: Norimasa ISHII, et., al.

Serial No.: Not Yet Assigned

Filing Date: Herewith

For: GLASS SUBSTRATE FOR INFORMATION RECORDING  
MEDIUM AND METHOD FOR MAUFACTURING THE SAME

JC20 Rec'd PCT/PTO 22 APR 2005  
Patent No.: 16169.6  
Group: Unknown

INFORMATION DISCLOSURE CITATIONS MADE BY APPLICANT

Foreign Patent Documents

<u>Examiner Initial*</u>	<u>Document Number</u>	<u>Date</u>	<u>Country</u>
LF 1	JP 02-032909	01/31/02	Japan

**References Cited by Applicants**

While the filing of Information Disclosure Statements is voluntary, the procedure is governed by the guidelines of Section 609 of the Manual of Patent Examining Procedure and 37 C.F.R. §§ 1.97 and 1.98. To be considered a proper Information Disclosure Statement, Form PTO-1449 shall be accompanied by a copy of each listed patent or publication or other item of information and a translation of the pertinent portions of foreign documents (if an existing translation is readily available to the applicant), an explanation of relevance of each reference not in the English language, and should be submitted in a timely manner as set out in MPEP Sec. 609.

Examiners will consider all citations submitted in conformance with 37 C.F.R. § 1.98 and MPEP Sec. 609 and place their initials adjacent the citations in the spaces provided on this form. Examiners will also initial citations not in conformance with the guidelines which may have been considered. A reference may be considered by the Examiner for any reason whether or not the citation is in full conformance with the guidelines. A line will be drawn through a citation if it is not in conformance with the guidelines AND has not been considered. A copy of the submitted form, as reviewed by the Examiner, will be returned to the applicant with the next communication. The original of the form will be entered into the application file.

Each citation initialed by the Examiner will be printed on the issued patent in the same manner as references cited by the Examiner on Form PTO-892.

The reference designations "A1," "A2," etc. (referring to Applicant's reference 1, Applicant's reference 2, etc.) will be used by the Examiner in the same manner as Examiner's reference designations "A," "B," "C," etc. on Office Action Form PTO-1142.

/Louis Falasco/

02/12/2007

Examiner:

Date Considered:

**\*EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.